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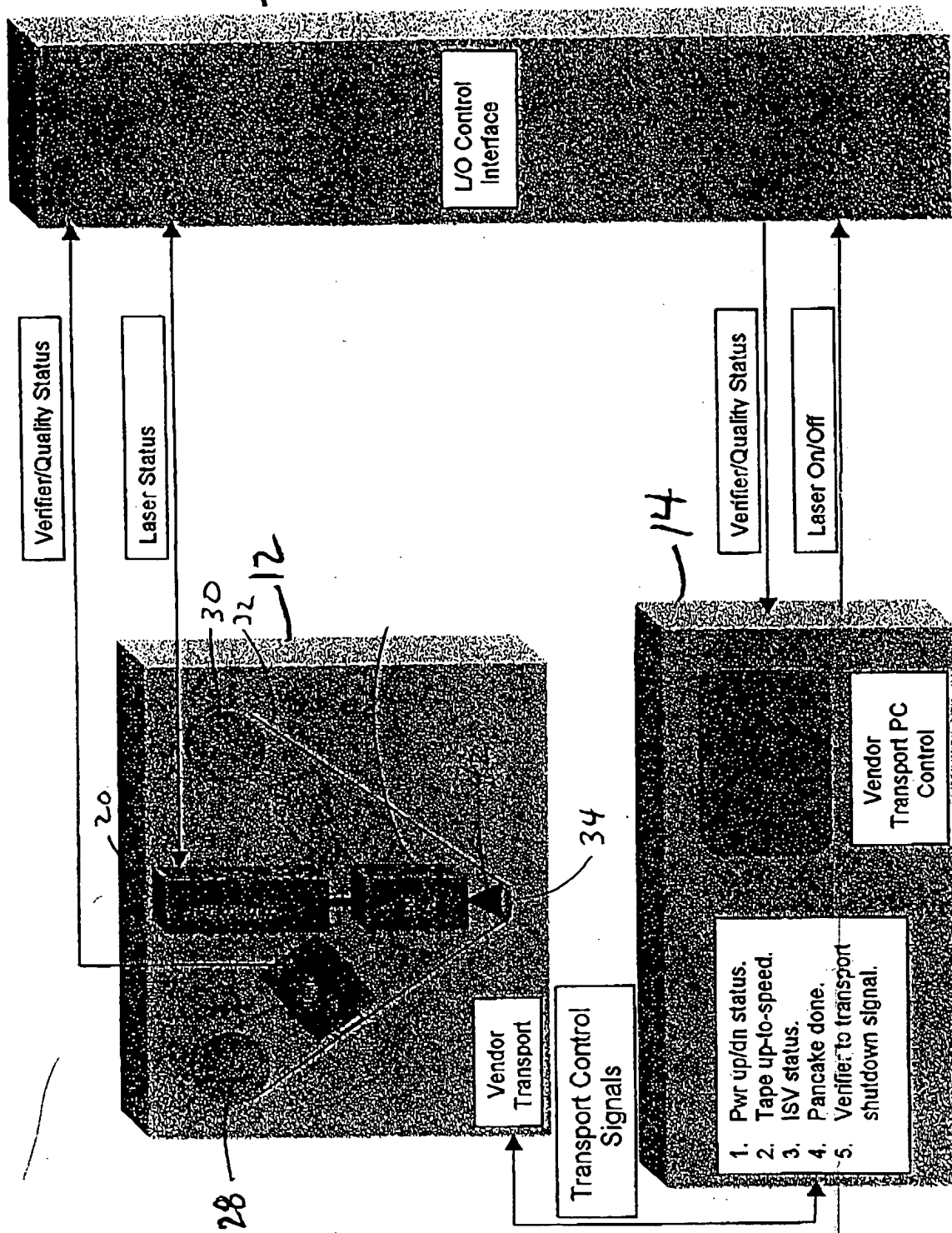


Fig. 1

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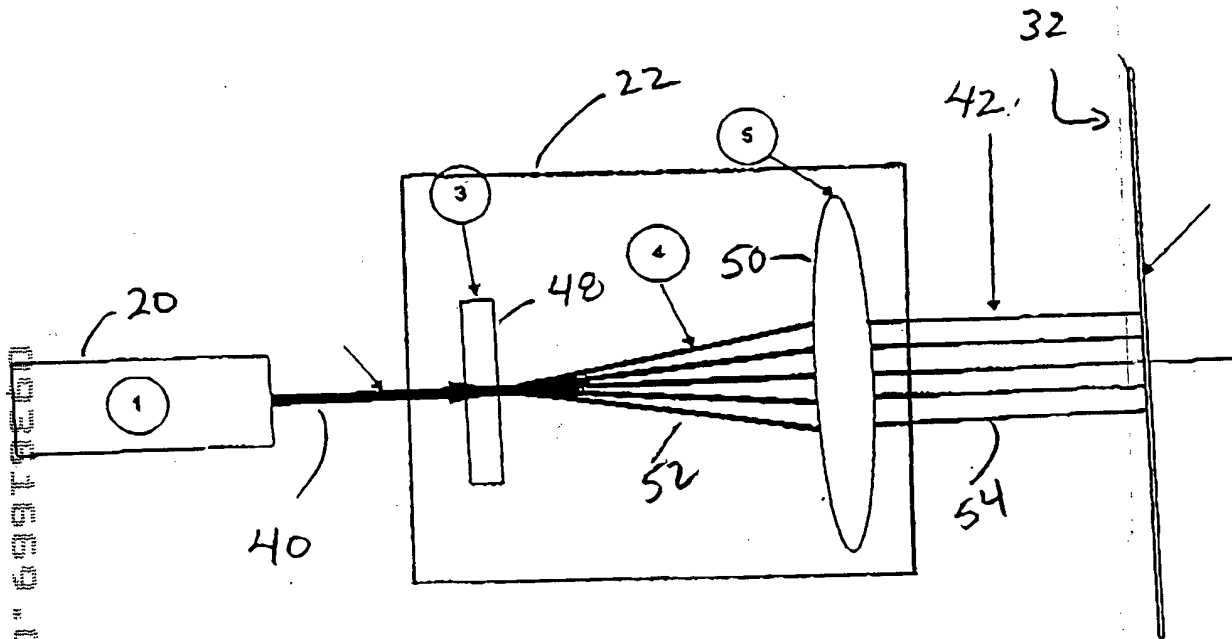


Fig. 2

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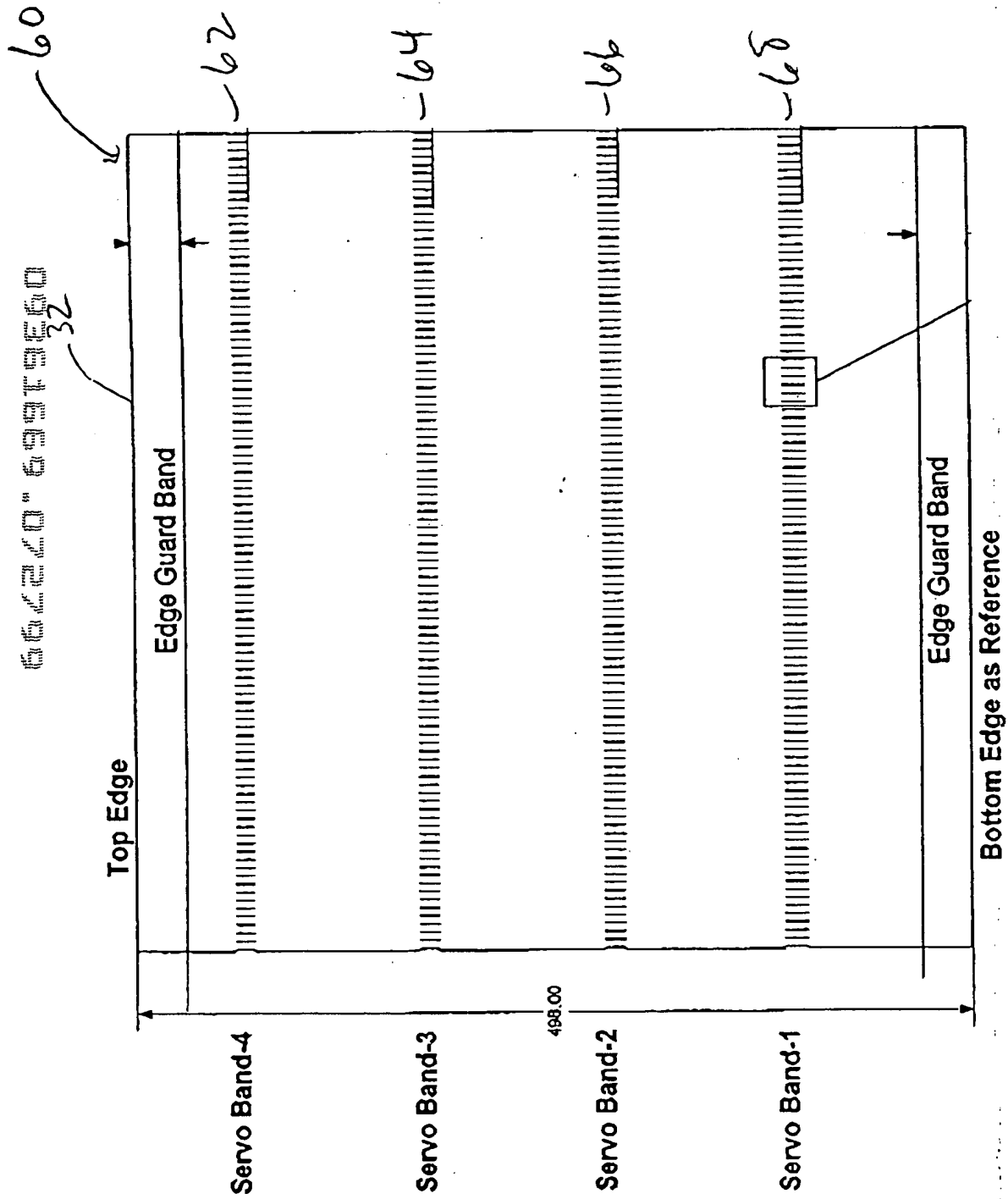


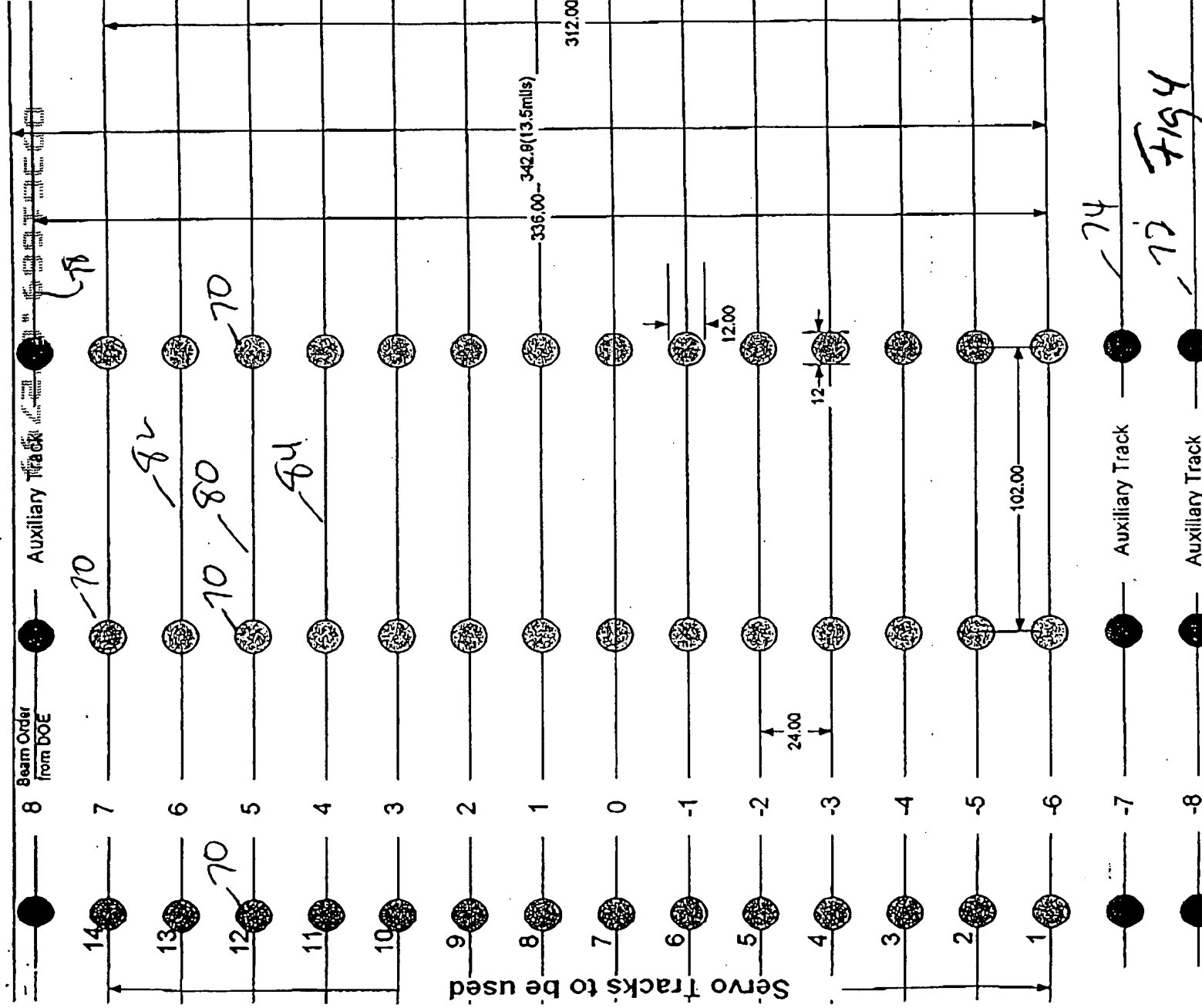
Fig 3

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Unit: micrometer

**-Rev.3**

**Hong Chen, AP&T,  
SSPG, Quantum Corp.**  
**3/2/99**



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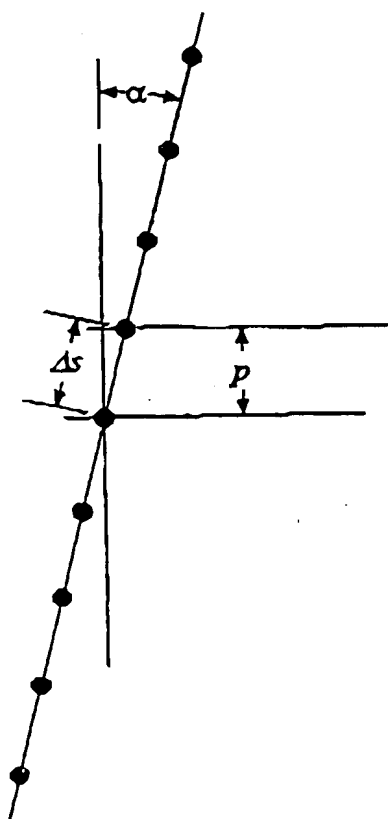


Fig 5

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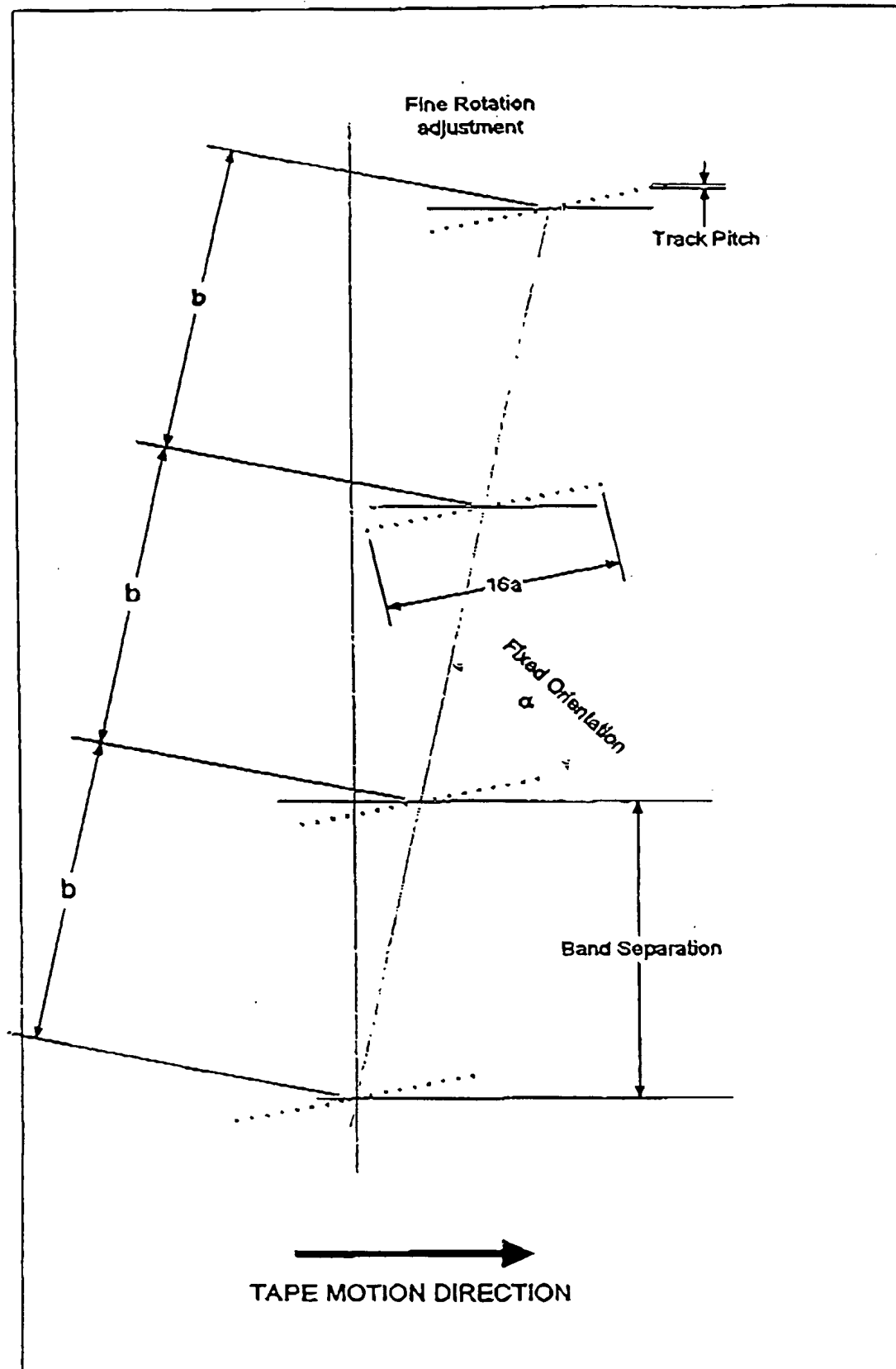


Fig 6

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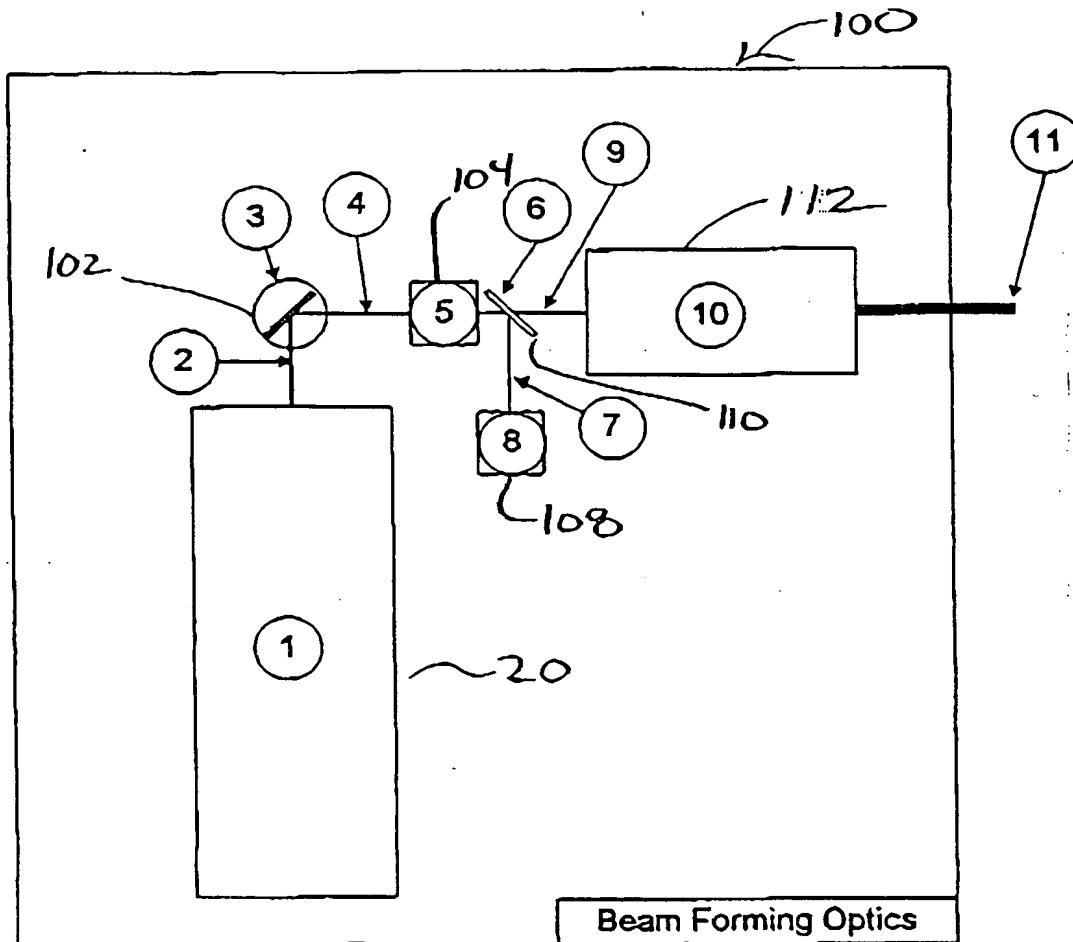


Fig. 7

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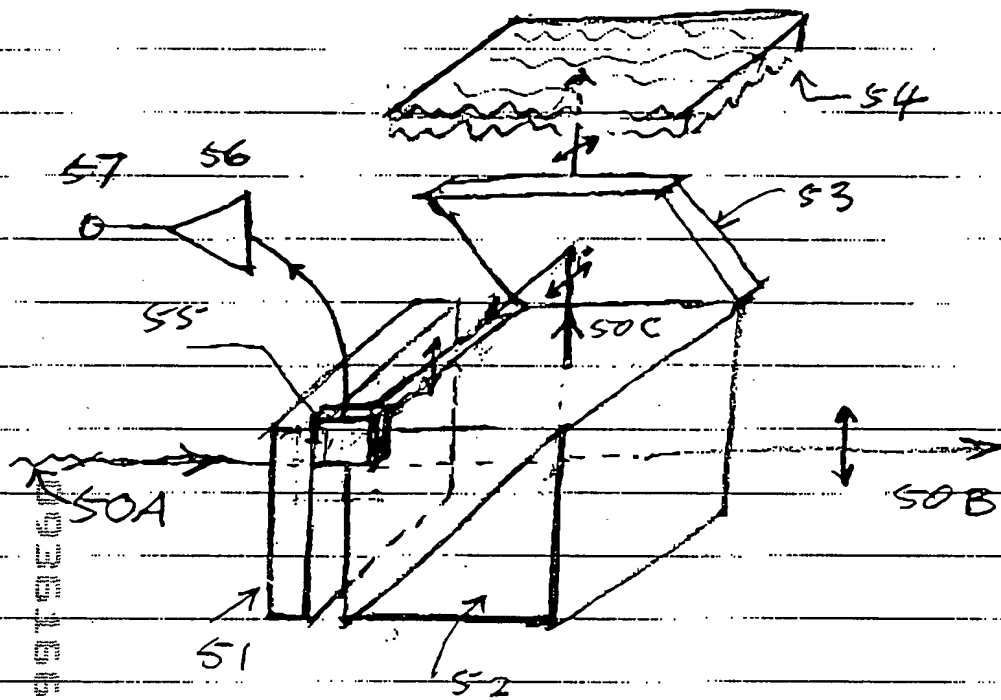


Fig. 8 Combined Attenuator and Power Monitor

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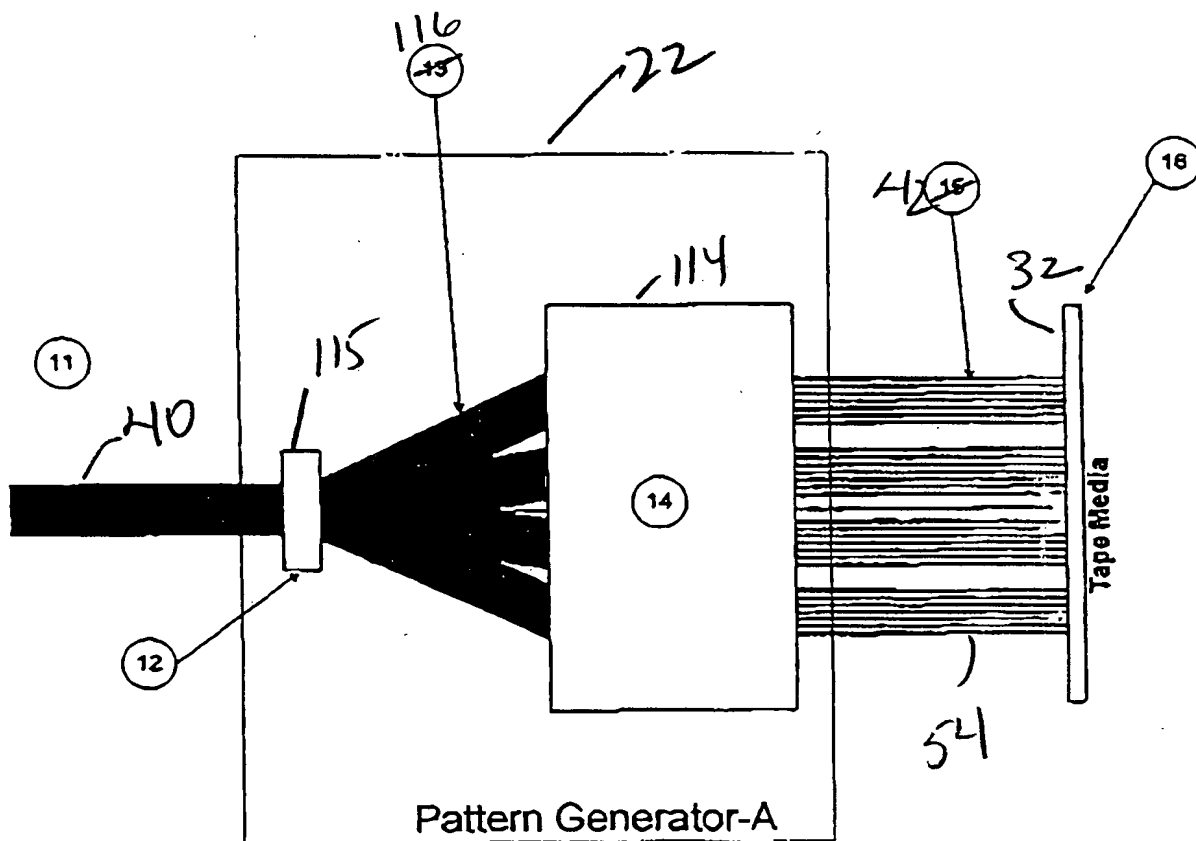


Fig 9

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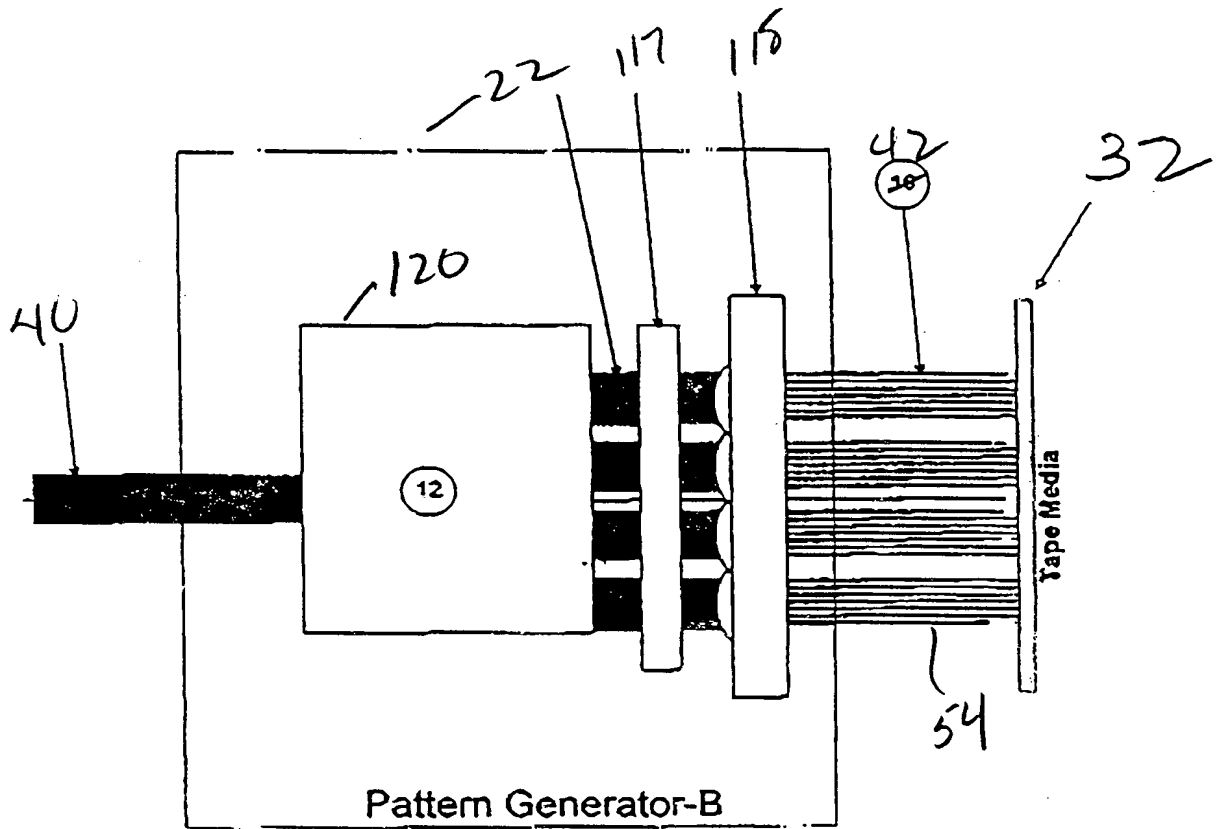


Fig. 10

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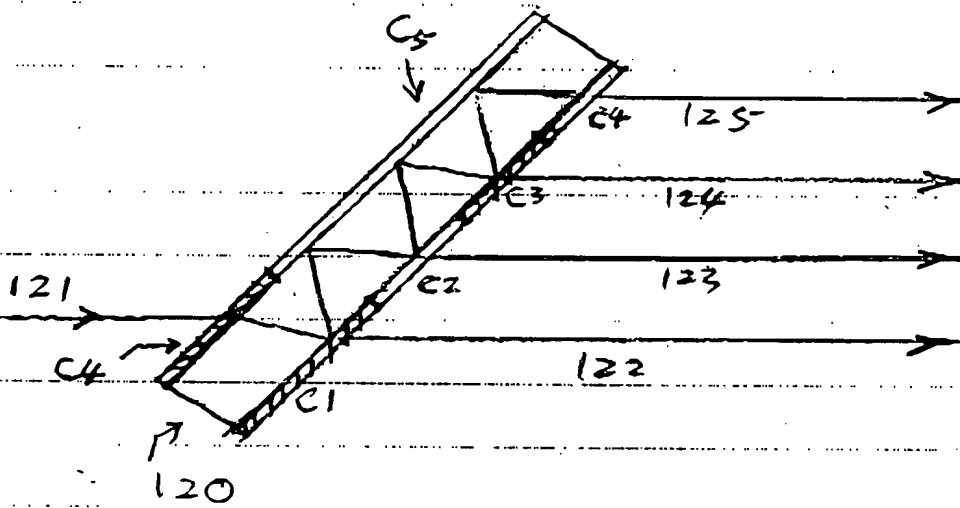
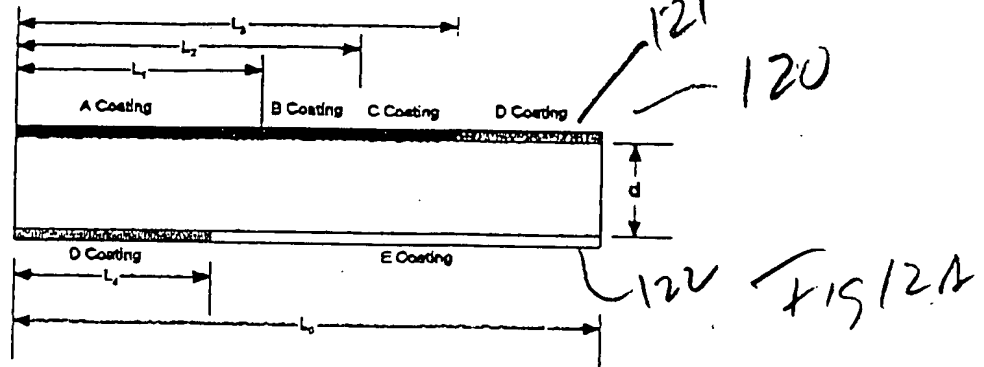


Fig. 11 Use of a segmented mirror to create 4 beams of equal intensity

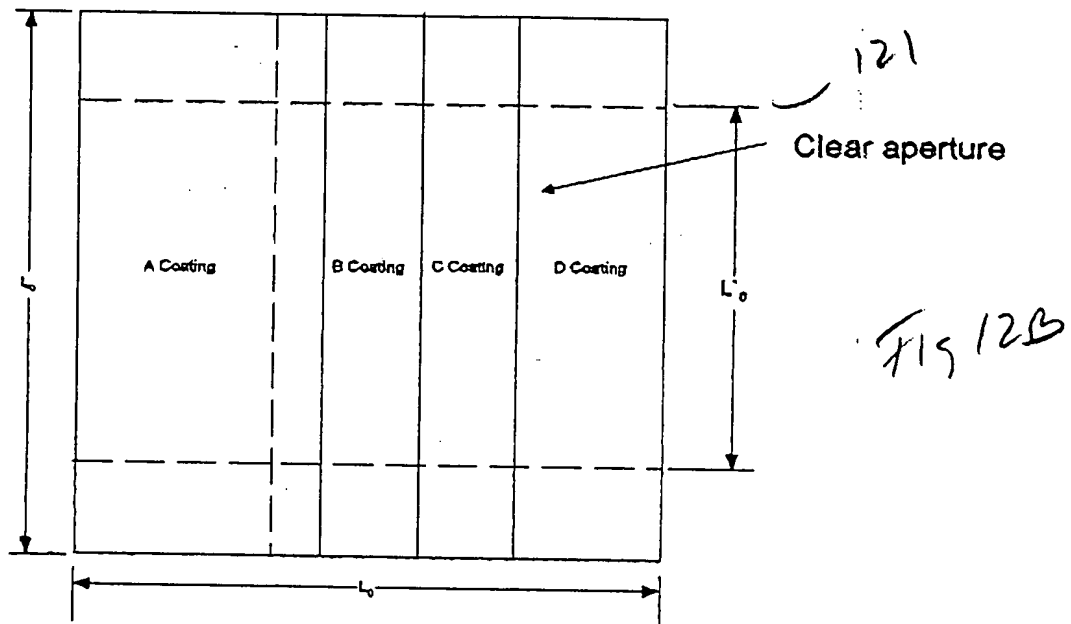
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Fig. 12

Side View



Top View



532nm

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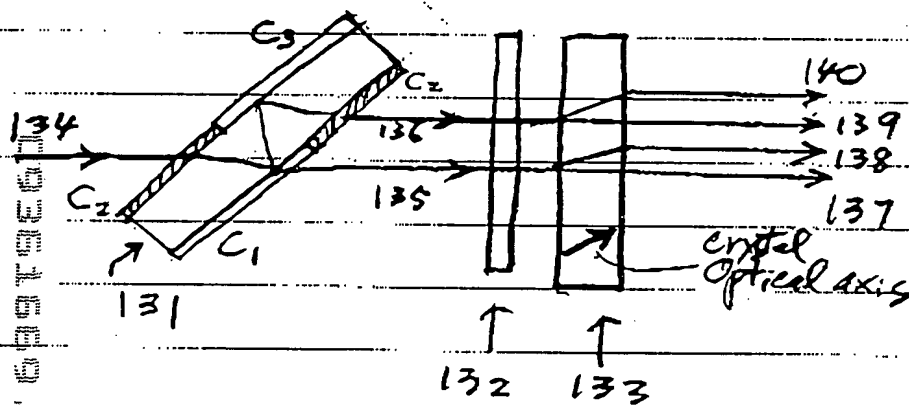


Fig. 13 Generation of multiple parallel beams by the combined use of a segmented mirror and a birefringent crystal plate

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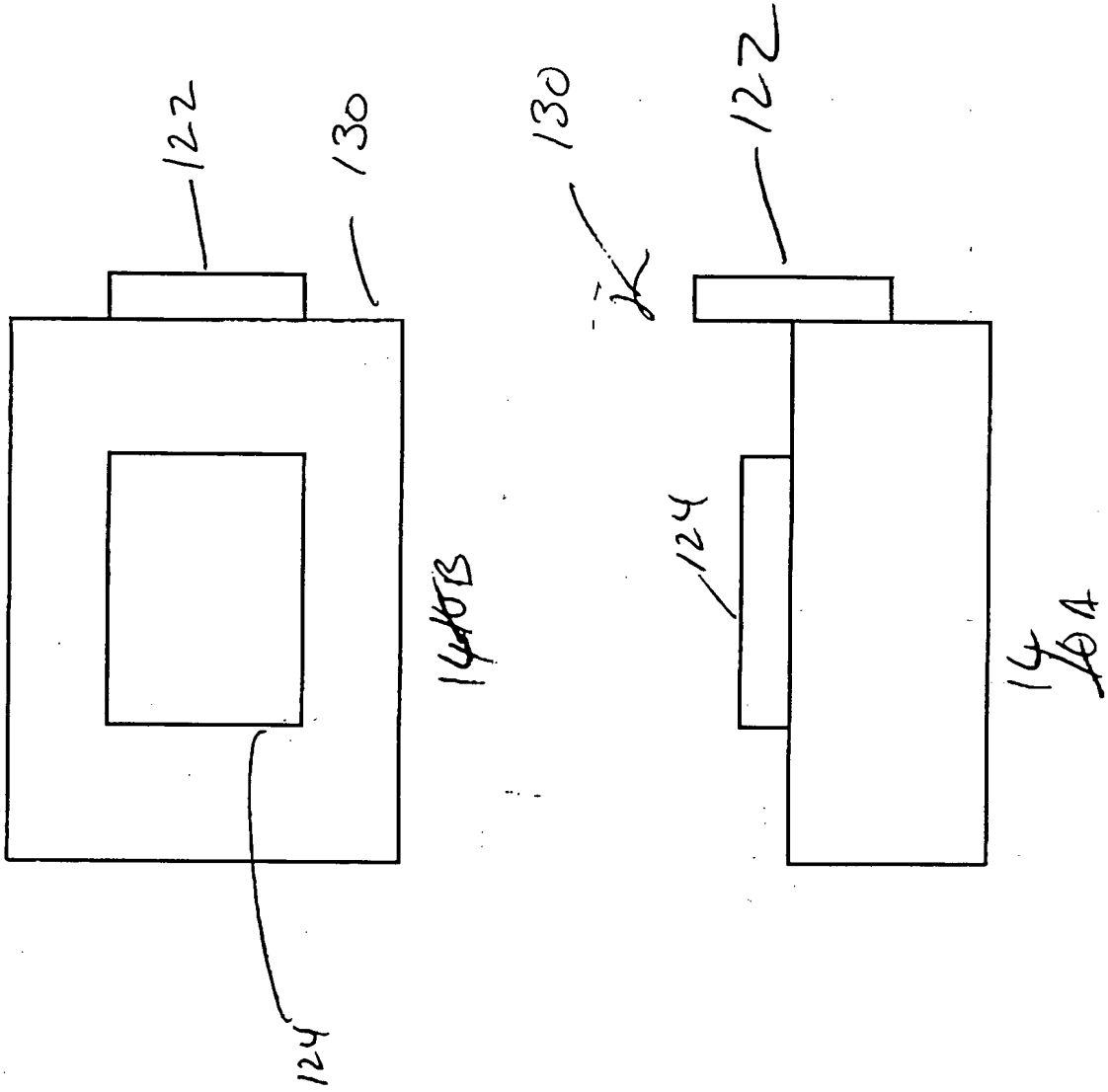


Fig. 14